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12/12/01



PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10020764	FILING DATE 12/12/2001	CLASS 438 2578	SUBCLASS 444	GAU 2811	EXAMINER Vikki Trinh
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**CONTINUING DATA VERIFIED:

No

** FOREIGN APPLICATIONS VERIFIED:

No

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO 01-807
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		
Verified and Acknowledged Examiners's initials		
TITLE : Substrate laser marking		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L/Rev. 12-94

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheets Drawg	Figs. Drawg
Primary Examiner		Print Fig	
PREPARED FOR ISSUE		Application Examiner	
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